Application Serial No. 09/875,501

| Response to March 18, 2004 Final OA

MI22-1741

JUN 1 7 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Filing Date June 4, 2001
Inventor Klaus F. Schuegraf et al.
Assignee Micron Technology, Inc.
Group Art Unit 2815
Examiner E. Ortiz
Attorney's Docket No. Ml22-1741
Title: Methods for Forming Wordlines, Transistor Gates, and Conductive Interconnects, and Wordline, Transistor Gate, and Conductive Interconnect
Structures

RESPONSE TO MARCH 18, 2004 FINAL OFFICE ACTION ACCOMPANYING REQUEST FOR CONTINUED EXAMINATION (RCE)

To:

Mail Stop RCE

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

From:

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Responsive to the Final Office Action dated March 18, 2004, Applicant amends and remarks as follows:

AMENDMENTS

Underlines indicate insertions and strikeouts indicate deletions.